INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 30, 2026

IGI Report Number	LG843628900
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL MIXED CUT
Measurements	12.57 X 8.27 X 4.67 MM

GRADING RESULTS

Carat Weight	3.28 CARATS
Color Grade	D
Clarity Grade	VVS 2

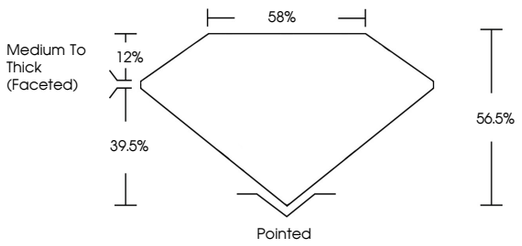
ADDITIONAL GRADING INFORMATION

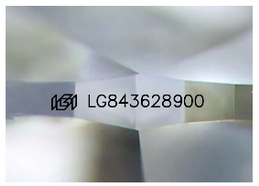
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG843628900

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG843628900
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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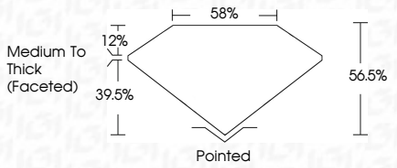
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IGI

September 30, 2026
IGI Report No LG843628900
OVAL MIXED CUT
12.57 X 8.27 X 4.67 MM
Carat Weight 3.28 CARATS
Color Grade D
Clarity Grade VVS 2
Depth 56.5%
Table 58%
Girdle Medium To Thick (Faceted)
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG843628900
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa